

<b>INFORMATION DISCLOSURE CITATION</b> <small>(Use several sheets if necessary)</small>				Docket Number (Optional) <b>H 2182</b>		Application Number <b>10/047,556</b>	
				Applicant(s) <b>Martin Klein et al.</b>			
				Filing Date <b>October 23, 2001</b>		Group Art Unit <b>2884</b>	

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 MAY 08 2006  
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U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS							
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FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS				<i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>			
SL		Advances in Gas Avalanche Photomultipliers - A. Breskin et al., Dept. of Particle Physics, The Weizmann Institute of Science 76100, Rehovot, Israel - Presented at Beaune99, The Second International Conference on New Developments in Photodetection, Beaune, France, June 21-25, 1999.					

EXAMINER <b>/Shun Lee/</b>	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.